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02/12/02

U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL NUM 10074287	FILING DATE 02/12/2002	CLASS 2.1 364	SUBCLASS 370,000	GAU 9742 2935	EXAMINER Fuqua
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**APPLICANTS: Mahawili Imad;

**CONTINUING DATA VERIFIED:

THIS APPLN CLAIMS BENEFIT OF 60/268,340 02/12/2001

Stf

** FOREIGN APPLICATIONS VERIFIED:

Stf

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	ATTORNEY DOCKET NO
35 USC 119 conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	MIC04 P-113
Verified and Acknowledged Examiners's initials <i>Stf</i>		
TITLE : Ultra fast rapid thermal processing chamber and method of use		

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
Assistant Examiner		DRAWING	
ISSUE FEE		Sheets Drwg.	Figs. Drwg.
Amount Due	Date Paid	Print Fig.	
Primary Examiner		Applicati n Examiner	
PREPARED F R ISSUE			
<input type="checkbox"/> TERMINAL DISCLAIMER		WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.	

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